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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

DT01 Rec'd PCT/PTO 28 DEC 2004

**INFORMATION DISCLOSURE
STATEMENT**Docket Number:
10191/3980Application Number
To be assignedFiling Date
HerewithExaminer
To be assignedArt Unit
To be assignedInvention Title
**DEVICE AND METHOD FOR PRODUCING
CHLORINE TRIFLUORIDE AND SYSTEM
FOR ETCHING SEMICONDUCTOR
SUBSTRATES USING THIS DEVICE**Inventor(s)
Frank LAERMER et al.

Address to:

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Commissioner For Patents
Alexandria, VA 22313-1450

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated on the modified PTO form 1449.

Dated:

12/28/04

By:

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	DOCKET NO. 10191/3980	SERIAL NO. 101519724 To be assigned
	APPLICANT Franz LAERMER	
	FILING DATE To be assigned	GROUP To be assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US 2002/074946 *	June 20, 2002	Tetsuya et al.			
	4,472,254 *	September 18, 1984	Dotson et al.			
	6,190,507 *	February 20, 2001	Bigelow et al.			

* Copy of reference is not enclosed because reference is cited and described in Search Report (copy of reference provided by the International Searching Authority).

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	00 51938 *	September 8, 2000	WO				
	2001 267241 *	September 28, 2001	JP				
	2 332 302 *	June 16, 1999	GB				
	199 19 469 *, **	November 2, 2000	DE				
	08-153711	June 11, 1996	JP			Abstract	
	43 17 623	December 1, 1994	DE			Abstract	

* Copy of reference is not enclosed because reference is cited and described in Search Report (copy of reference provided by the International Searching Authority).

** Described in the specification.

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Joudan et al., "Recent Developments in Fluorine Chemistry for Microelectronic Applications – Some Examples at Comurhex", Journal of Fluorine Chemistry, Elsevier Seguoia, Lausanne, CH, Bd. 107, Nr. 2, February 2001, Pages 255-264, XP004315006, ISSN: 0022-1139, Page 260-262. *
	Hofmann-Rüdorff, "Textbook of Inorganic Chemistry", 21 st Edition, 1973, pgs. 259 et. sqq. **

* Copy of reference is not enclosed because reference is cited and described in Search Report (copy of reference provided by the International Searching Authority).

** Described in the specification.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	